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PATENT APPLICATION

#13

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
Haruhito ONO et al.) : Examiner: I. Soward
Application No.: 09/819,737) : Group Art Unit: 2822
Filed: March 29, 2001) :
For: ELECTROOPTIC SYSTEM ARRAY,)
CHARGED-PARTICLE BEAM) :
EXPOSURE APPARATUS USING THE) February 6, 2003
SAME, AND DEVICE)
MANUFACTURING METHOD)

Commissioner for Patents
Washington, D.C. 20231

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Sir:

Please permit C.T. Tran of FITZPATRICK, CELLA, HARPER & SCINTO to inspect and make copies of any and all papers in the Patent and Trademark Office file of the above-identified application.

Applicants' undersigned attorney may be reached in our Washington, D.C. office by telephone at (202) 530-1010. All correspondence should continue to be directed to our address given below.

Respectfully submitted,

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